

PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q64059

Shigeo ISHIKAWA

Group Art Unit: 2823

Confirmation No.: 8684

Appln. No.: 09/832,093

Examiner: Khiem D. Nguyen

Filed: April 11, 2001

FILM FORMING METHOD IN WHICH FLOW RATE IS SWITCHED For:

SUBMISSION OF DRAWINGS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Submitted herewith please find one sheet of drawing in compliance with 37 C.F.R. § 1.84. The Examiner is respectfully requested to acknowledge receipt of this drawing.

The submitted drawing is believed to obviate the informalities indicated in the Office Action dated February 13, 2003.

Respectfully submitted,

Registration No. 40,641

SUGHRUE MION, PLLC Telephone: (202) 293-7060

Facsimile: (202) 293-7860

WASHINGTON OFFICE

23373

PATENT TRADEMARK OFFICE

Date: May 13, 2003

He words





Howard L. Bernstein, Esq.

T 202-663-7937 hbernstein@sughrue.com

May 13, 2003

## <u>VIA AIRMAIL</u>

Mr. Minoru Kudoh KUDOH PATENT OFFICE Kadoya Building 6F 24-10, Minamiooi 6-chome Shinagawa-ku Tokyo 140-0013 JAPAN

Re:

U.S. Patent Application No.: 09/832,093

Inventor: Shigeo ISHIKAWA Assignee: NEC CORPORATION

Report Filing of Amendment and a Submission of Drawings

Your Ref:

01USFP639-MK

Our Ref:

Q64059

Due Date:

None

Dear Mr. Kudoh:

In accordance with the instructions in your facsimile of May 7, 2003, we prepared and filed an Amendment Under 37 C.F.R. §1.111 and a Submission of Drawings in the above-identified application. Two (2) copies of the papers as filed in the U.S. Patent and Trademark Office today are enclosed for your records.

Additionally, please find enclosed our debit note for services and disbursements. We will keep you informed of all further developments with respect to the prosecution of this application. Thank you for allowing us to be of service.

Very truly yours,

Howard L. Bernstein

Jennifer M. Hayes

HLB/JMH/sls Enclosures CONFIRMATION COPY TECHNOLOGY CENTER 2800

MAY IL 2003

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## **FILING RECEIPT** PLEASE DATE STAMP AND RETURN TO US - BOX 235X

Shigeo ISHIKAWA

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FILM FORMING METHOD IN WHICH FLOW RATE IS SWITCHED For:

PAPER(S) FILED ENTITLED:

1. Amendment Under 37 C.F.R. §1.111

2. Submission of Drawings (with 1 sheet of drawings)

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ATTORNEY/SEC: HLB/JMH/sls

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